



AF
Zhu

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **OHASHI, Hitoshi et al.**

Group Art Unit: 1762

Serial No.: 10/047,992

Examiner: **Brian K. TALBOT**

Filed: **January 17, 2002**

P.T.O. Confirmation No.: 5363

For: **METHOD AND APPARATUS FOR FORMING
ELECTRIC CIRCUIT FIXING THE SEMICONDUCTOR
DEVICE USING SUBSTRATE JIG**

AMENDMENT UNDER 37 CFR §1.116
- EXPEDITED RESPONSE -
GROUP ART UNIT 1762

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

December 21, 2006

Sir:

In response to the Final Office Action dated **September 26, 2006**, please amend the
above-identified application as follows: